

Notice of References Cited	Application/Control No. 10/699,991	Applicant(s)/Patent Under Reexamination LERNER ET AL.	
	Examiner Jennifer Kim	Art Unit 1617	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-4,150,113	04-1979	Hoogendoorn et al.	424/50
	B	US-			
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	D	US-			
	E	US-			
	F	US-			
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	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP9249562	09-1997	Japan	Obata Nobuko et al.	-----
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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